

<b>Notice of References Cited</b>	Application/Control No. 10/707,299	Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Elizabeth A. Rielley	Art Unit 2879	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,798,134	09-2004	Wang, Wen-Chun	313/504
	B	US-6,130,001	10-2000	Shi et al.	428/690
	C	US-			
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
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	R					
	S					
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**NON-PATENT DOCUMENTS**

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